



Attorney Docket No.: VLSI-2759

GP 3724

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application

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In re Application

Inventor(s): Charles Franklin Drill and Milind Weling

Application No.: 08/824,633

Filed: 03/27/97

Title: A CUSTOMIZED POLISHING PAD FOR SELECTIVE PROCESS PERFORMANCE DURING CHEMICAL MECHANICAL POLISHING

Assistant Commissioner for Patents
Washington, D.C. 20231

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Group 3700

NOTIFICATION OF FILING OF CONTINUING APPLICATION

☒ Notification is hereby being made of the filing of an CPA application for this case

☒ concurrently herewith.
☐ on

Please direct all correspondence concerning the above-identified application to the following address:

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Respectfully submitted,

Date: November 22, 1999

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